

Application/Control No.	Applicant(s)/Patent under Reexamination KIM, HYON T.	
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Examiner	Art Unit	
Hai V. Nauven	2142	

SEARCHED					
Class	Subclass	Date	Examiner		
370	396	9/14/2005	HN		
370	400	9/14/2005	HN		
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
EAST Search Updated	9/14/2005	HN		